

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 15, 2010

In re the Application of

Makoto IIDA et al.

Application No.: 10/586,953

Filed: July 25, 2006



Group Art Unit: 1714

Examiner: G. RAO

Docket No.: 128832

For: A SILICON SINGLE CRYSTAL, A SILICON WAFER, AN APPARATUS FOR PRODUCING THE SAME, AND A METHOD FOR PRODUCING THE SAME

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 24, 2010, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 230568 in the amount of \$130.00 in payment for:

- X Extension fee for response within first month pursuant to §1.136(a) (\$130.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$490.00)
 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1,110.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION</p> <p>Please grant any extension necessary for entry of this filing; Charge any fee due to our Deposit Account No. 15-0461</p>
